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2823

Serial No. 09/899,784

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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**AUG 15 2003**  
**TECHNOLOGY CENTER 2800**

In re the Patent Application of

Inventor(s): Dong-Su Kim

Group Art Unit: 2823

Serial No.: 09/899,784

Examiner: Toledo, Fernando L

Filing Date: July 5, 2001

For: Method of Fabricating Silica Microstructures

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Va 22313-1450

**AMENDMENT**

Sir:

In response to the Office Action dated May 16, 2003, please amend the above-identified application as follows.